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PATENT
Atty Docket No. KLAC0012

I HEREBY CERTIFY THAT ON AUGUST 23, 2004, THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450.

A handwritten signature in black ink, appearing to read "STEVEN W. SMYRSKI".

STEVEN W. SMYRSKI

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

CHRISTOPHER FAIRLEY, ET AL.

Title: CONFOCAL WAFER INSPECTION
METHOD AND APPARATUS USING FLY
LENS ARRANGEMENT

Serial No.: 09/533,203

Filed: MARCH 23, 2000

Group Art Unit: 2878

Examiner: Thanh X. Luu

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 21, 2004, please enter the following amendments and consider the following remarks in connection with the above-identified patent application.

Title

Please change the title of the application to:

Confocal Wafer Inspection Method and Apparatus Using Fly Lens Arrangement